

05-07-02 176245
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Tony P. Chiang et al.
Assignee: Angstrom Systems, Inc.
Title: Varying Conductance Out Of A Process Region To Control Gas Flux In
An ALD Reactor
Application No.: 10/027,592 Filing Date: December 19, 2001
Examiner: Unknown Group Art Unit: Unknown
Docket No.: M-11466-8C US

San Jose, California
27 March 2002

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicants wish to call the documents listed on the enclosed form PTO-1449 to the attention of the Examiner in the above-identified application.

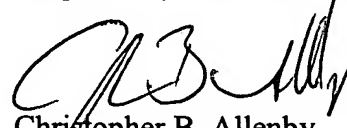
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3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

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Respectfully submitted,


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